



JFW

Atty. Dkt. No. 039262-0143

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tadahiro OHMI et al.
Title: SEMICONDUCTOR DEVICE
AND SEMICONDUCTOR
DEVICE MANUFACTURING
METHOD
Appl. No.: 10/553,416 ✓
International Filing Date: 4/13/2004
371(c) Date: 10/17/2005
Examiner: Thien F. Tran
Art Unit: 2811
Confirmation Number: 1517

AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated April 17, 2008, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 7 of this document.

Please amend the application as follows: